High Power Couplers for Higgs Factory

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Coupler Specification for Higgs Factory

Machine Parameters	FCC (TLEP)	СерС
Beam Energy	175 GeV	120 GeV
Beam Current	6.6 mA	16.6 mA
Circumference	100 km	54 km
Total RF Voltage	11 GV	6.9 GV
Coupler Parameters		
RF Frequency	802 MHz	650 MHz
Accelerating Gradient	20 MV/m	15.5 MV/m
Cavity Effective Length	0.93 m (5-cell)	1.15 m (5-cell)
Required RF Power	CW, 125 kW	CW, 260 kW
External Q of Coupler	5.4 x 10 ⁶	2.4 x 10 ⁶

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Essential Consideration for Input Couplers



High Power Input Coupler

1. Input coupler is one of the most critical component of an SRF system. 2. Design of an input coupler strongly depends on a cryomodule structure.

- RF power capability : ($P_{RF} = I_{beam} * V_{acc} * \cos\phi$)
- Coupler type : coaxial or waveguide
- Ceramics window type : disk or cylindrical
- Number of windows : single or double
- Coupling with cavity : fixed or adjustable
- Cooling method : air, He-gas, N₂-gas or water
- Bias voltage : useful or needless



Important Technical Issues for Input Couplers

- Ceramics window : material, purity
- Metalizing of ceramics
- Copper plating : thickness, RRR, adhesion, pits, uniformity
- TiN coating : thickness, uniformity
- Joining by Brazing
- Welding by TIG, Laser, E-beam
- RF properties
- Thermal characteristics
- Mechanical analysis
- Multipacting simulation
- Cleaning procedure
- Assembly in clean room



from Coupler Design to Beam Operation



Design/Calculation



Fabrication



RF measurement



Cleaning/Assembly Pumping/Baking



Conditioning at test stand





Conditioning at RT in cryomodule



High power test at LT and, then Operation with beam

TRISTAN-type High Power Input Couplers



Original design : 508 MHz TRISTAN Input Coupler S. Noguchi, E. Kako, K. Kubo (4th SRF-WS, 1989)



508 MHz **KEKB** Input Coupler (KEK)



704 MHz HIPP Input Coupler (CEA)





805 MHz SNS Input Coupler (ORNL)



1300 MHz cERL Injector Input Coupler (KEK)

972 MHz ADS Input Coupler (KEK)



TRISTAN-type RF Window

Tristan-type coaxial disk ceramics RF window with choke structure







RF windows after 1st brazing

 Al_2O_3 ceramics with metalizing



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High Power Performance of TRISTAN-type Couplers

Facility	Frequency	Window type Coupling	Maximum RF Power
TRISTAN /KEK	508 MHz	Coax. Disk Fixed	Test-stand,200 kW, CWOperation,70 kW, CW
KEKB /KEK	508 MHz	Coax. Disk Fixed	Test-stand,800 kW, CWOperation,380 kW, CW
HIPPI /CEA	704 MHz	Coax. Disk Fixed	Test-stand, 1.2 MW, pulse (10% duty)
SNS /ORNL	805 MHz	Coax. Disk Fixed	Test-stand, 2 MW, pulse Operation, 350 kW, pulse
ADS /KEK-JAERI	972 MHz	Coax. Disk Fixed	Test-stand, 2 MW, pulse Operation, 350 kW, pulse
cERL-Inj. /KEK	1300 MHz	Coax. Disk Fixed	Test-stand,40 kW, CWOperation,10 kW, CW

All of these RF windows were fabricated by Toshiba-ED company.



High Power Couplers at CEA-Saclay (1)



704 MHz HIPPI couplers high power tests



- Tested up to 1.2 MW, 10% duty cycle on room temperature test stand
- Tested up to 1MW full reflection, 10% duty cycle on SRF cavity operating in a horizontal test cryostat





RF Conditioning Results Pulse mode (2 ms, 50Hz) : 1.2 MW (10% duty)





By G. Devanz (CEA)



High Power Couplers at CEA-Saclay (2)

ESS 704 MHz power coupler peak power

	Optimus	Unit
Eacc Spoke	9	MV/m
V Spoke	5.74 (L = 3 βλ /2)	MV
Pcoupler Spoke	330	kW
N Spoke modules	13	_
Еасс мр	16.79	MV/m
V мβ	14.36 (L = 6 β'λ' /2)	MV
P _{coupler Mβ}	860	kW
N Mβ modules	9	
Еасс нв	19.94	MV/m
V нβ	18.24 (L = 5 β"λ' /2)	MV
P _{coupler Hβ}	(1100)	kW
N H β modules	21	D. Mc Gi

Updated for ESS tests :

- Peak power : 1MW (1.2 MW for a short period)
- Repetition rate up to : 25 Hz
- RF pulse length : 3.1 ms





High Power Couplers at CERN (1)



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High Power Couplers at CERN (2)

704 MHz SPL Input coupler

RF Characteristics		
f ₀	704.4 MHz	
Power levels	1000 kW pulsed 0.4 + 1.2 + 0.4 = 2.0 ms 50 Hz (20 ms) 100 kW average	
Cavity design gradient	19-25 MV/m	
Q _{ext} of input coupler	1.2 x 10 ⁶	
Input line Ø	$100 / 43.5 \text{ mm} = 50 \Omega$ (from the cavity design)	
Waveguides	WR 1150	

Technical Choices

Single window coupler

Fixed coupler

With a Double Walled Tube

Mounted in clean room with its double walled tube

Vertically below the cavity and will be a support for the cavity (first time worldwide)

With a HV DC biasing capacitor

Air cooled

By E. Montesinois (CERN)

SPL Fundamental Power **Coupler Project**



Both designs will have the same

Double walled tube

Matching waveguide without doorknob

Contacts ring including DC capacitor

> Interface to cryomodule flange & RF + vacuum gasket

Pulse mode (2 ms, 50Hz)

Disk window Coupler **RF Conditioning Results**

Cylindrical window Coupler

250 kW **SW** :

TW: 1000 kW





High Power Couplers at BNL



Figure 7: Typical vacuum trip during conditioning.

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High Power Couplers at IHEP-Beijing

Input power coupler of the main ring SRF cavity (650 MHz)

BEPCII 500MHz SCC coupler is taken as the baseline for CEPC main ring SRF cavity

input power coupler



Test-stand, 420 kW, CW

Input power coupler of the booster SRF cavity (1300 MHz)

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By T. Huang (IHEP)

Consideration of Input Coupler for Higgs Factory (1)

Facility	Frequency	Window, DC-Bias, Coupling, Cooling	Maximum RF Power
CepC /IHEP	650 MHz	Under design	Spec., 260 kW, CW
SRF-Gun /BNL	704 MHz	Coax. Disk, no-Bias Fixed, water & He gas	Test-stand, 125 kW, CW 250 kW, pulse (20% duty)
HIPPI /CEA	704 MHz	Coax. Disk, no-Bias Fixed, water & He gas	Test-stand, 1.2 MW, pulse (10% duty)
SPL /CERN	704 MHz	Disk/Cylind., DC-Bias Fixed, & He gas	Test-stand, 1.0 MW, pulse (10% duty)
ESS /CEA	704 MHz	Coax. Disk, DC-Bias Fixed, water & He gas	Specification, 1.2 MW, pulse (4% duty)
SNS /ORNL	805 MHz	Coax. Disk, DC-Bias Fixed, water & He gas	Test-stand, 2 MW, pulse Operation, 350 kW, pulse
FCC /CERN	802 MHz	Under design	Spec., 125 kW, CW

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Consideration of Input Coupler for Higgs Factory (2)

Requirement	FCC (TLEP)	СерС
Frequency	802 MHz	650 MHz
RF power	125 kW, CW	260 kW, CW
Beam current	varied / (fixed)	varied / (fixed)
Operating <i>E</i> _{acc}	varied / (fixed)	varied / (fixed)
Adjustable coupling	yes / (no)	yes / (no)
Range of QL / (Fixed)	- x 10 ⁶ / (5.4 x 10 ⁶)	- x 10 ⁶ / (2.4 x 10 ⁶)
Coupler type	coaxial	coaxial
RF window	single warm window	single warm window
Ceramics window	coaxial disk / cylindrical	coaxial disk
Bias voltage	yes	yes
Cooling method	inner conductor : water outer conductor : He gas	inner conductor : water outer conductor : N ₂ gas

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Summary

- Coaxial CW high power input couplers with a single warm RF window have been developing in the frequency range of 500 – 1300 MHz at the power level higher than 100 kW in many laboratories of the world.
- Design studies of high power couplers with 802 MHz, 125 kW-CW for FCC and 650 MHz, 260 kW-CW for CepC should be started as soon as possible.
- Fabrication of the prototype high power couplers and RF conditioning at a test-stand should be carried out at an early stage.



Thank you for your attention.

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